

<b>Notice of References Cited</b>	Application/Control No. 09/932,866	Applicant(s)/Patent Under Reexamination CHAUVEL ET AL.	
	Examiner Hong C Kim	Art Unit 2186	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,721,325	04-2004	Duckering et al.	370/395.4
	B	US-6,684,280	01-2004	Chauvel et al.	710/244
	C	US-5,884,051	03-1999	Schaffer et al.	710/107
	D	US-5,379,434	01-1995	DiBrino, Michael T.	710/264
	E	US-5,339,443	08-1994	Lockwood, James M.	710/244
	F	US-5,333,319	07-1994	Silen, Stuart L.	718/103
	G	US-5,263,163	11-1993	Holt et al.	710/242
	H	US-5,157,654	10-1992	Cisneros, Arturo	370/414
	I	US-4,633,394	12-1986	Georgiou et al.	710/240
	J	US-2002/0112106	08-2002	Henehan et al.	710/113
	K	US-2002/0065867	05-2002	Chauvel, Gerard	709/104
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	EP 1182551 A2	02-2002	European Patent	CHAUVEL, GERARD	G06F 09/46
	O	EP 1182538 A2	02-2002	European Patent	CHAUVEL et al.	G06F 11/34
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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